

**Search Notes**

Application/Control No.

10/801,830

Examiner

John Kim

Applicant(s)/Patent under  
Reexamination

CHEVALLET ET AL.

Art Unit

1723

**SEARCHED**

Class	Subclass	Date	Examiner
210	85, 86, 87, 97, 104, 134, 143	5/10/2006	JK
	195.1		
	195.2		
	252, 258		
	257.1		
	321.6		
	321.65		
	645, 646		
	650, 739		
604	4.01 5.01		
	5.04 6.01		
	6.04 6.09		
	6.11		

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Inventor Name Search	5/10/2006	JK
EAST Search Note	5/10/2006	JK